

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	: Tois et al.
App. No	: 10/678,766
Filed	: October 2, 2003
For	: METHOD OF GROWING OXIDE THIN FILMS
Examiner	: Matthew J. Song
Art Unit	: 1792
Conf No.	: 1629

## RESPONSE TO FINAL OFFICE ACTION

**Mail Stop AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Final Office Action electronically sent on April 1, 2010. Consideration of the following remarks is respectfully requested.

The Claims are reflected in the **Listing of Claims** which begins on page 2 of this paper.

**Summary of Interview** begins on page 7 of this paper.

**Remarks** begin on page 8 of this paper.